

Investigation on AIP as the heterogeneous nucleus of Mg₂Si in Al–Mg₂Si alloys by experimental observation and first-principles calculation

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ARTICLE INFO

Article history:

Received 27 September 2017

Received in revised form 20 November 2017

Accepted 20 November 2017

Available online 26 November 2017

Keywords:

AIP

Al–Mg₂Si alloys

First-principles calculation

Heterogeneous nucleus

ABSTRACT

The microstructural evolution of primary Mg₂Si in Al–20%Mg₂Si with Al–3%P master alloy was observed by scanning electron microscope. And the interfacial properties of AIP/Mg₂Si interface were investigated using first-principles calculations. The calculation results show that AIP(1 0 0)/Mg₂Si(2 1 1) and AIP(3 3 1)/Mg₂Si(1 1 0) interfaces can form steadily. P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface with the largest work of adhesion (4.13 J/m²) is theoretically the most stable. The interfacial electronic structure reveals that there are covalent Si–Al, Si–P and Mg–P bonds existing between AIP and Mg₂Si slabs. Due to the AIP particles as effective heterogeneous nucleus of Mg₂Si, primary Mg₂Si particles change from dendrite to octahedron/truncated octahedron, and their sizes decrease to ~20 μm.

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Introduction

Magnesium silicide, Mg₂Si, is a hard intermetallic compound with high melting point (1085 °C). It exhibits low density (1.99 × 10³ kgm⁻³), low thermal expansion coefficient (7.5 × 10⁻⁶ K⁻¹), high hardness (4.5 × 10⁹ Nm⁻²) and reasonably high elastic modulus (120 GPa) [1,2]. As particle-reinforced structural materials, Al–Mg₂Si alloys have been widely used in many fields with their excellent properties [3]. In as-cast hypereutectic Al–Mg₂Si alloys, primary Mg₂Si shows enormous dendrite (irregular shape) or fine polyhedron (perfect/imperfect octahedron and hopper).

The mechanical properties of Al–Mg₂Si alloys are dependent upon the morphology, size and distribution of Mg₂Si phase. Addition of refiners or modifiers is an effective method and has been adopted to control primary Mg₂Si particles with desirable shapes and sizes, such as P, Sr, Sb, Na, Li [4–14]. In the previous paper, it was found that AIP particles could act as the nuclei of primary Mg₂Si [12]. Coarse Mg₂Si dendrites evolve into numerous fine octahedron or truncated octahedron particles by increase of the Mg₂Si crystal nuclei, resulting in the increase of tensile strength of Al–Mg₂Si alloys [3,12]. The effectiveness of AIP as the heterogeneous nucleus of Mg₂Si has also been studied by mismatch theory [12]. However, mismatch theory is limited on analyzing the effective-

ness of heterogeneous nucleation but can not study the nucleation interfacial properties directly [15,16].

In recent years, first-principles method based on density functional theory (DFT) has been widely utilized to study the nucleation and interface [17–19], including the interface atomic arrangement rule and bonding condition, interfacial adhesion work and interfacial energy during the nucleation process. S. Liu et al. [20] calculated the interface properties of Fe₃Cr₄C₃ (0 0 0 1)/TiC (1 1 1) interface by first-principles method, and revealed that TiC in Fe–Cr–C–Ti alloy was the heterogeneous nucleus of primary M₇C₃. First-principles calculations were also employed to research the Mg/Al₂MgC₂ heterogeneous nucleation interfaces by H. L Wang et al. [21]. The interfacial structure and electronic properties were studied, and the results suggested that Al₂MgC₂ could be the potent crystal nucleus of α-Mg grains in the solidification of carbon-inoculated Mg–Al alloy. Y.F. Han [22] calculated the atomic structure, adhesion, and interfacial energy of Al/TiB₂ interfaces, and analyzed the mechanism of TiB₂ as the heterogeneous nuclei of the α-Al phase in Al alloys by first-principles.

In this work, the morphological evolution of primary Mg₂Si in Al–20%Mg₂Si alloy with the addition of Al–3%P master alloy was observed by experimental method. Moreover, the electronic structure and adhesion work of AIP/Mg₂Si interfaces (with small lattice disregistry) were calculated using the first-principles method and stacking sequence of Mg, Si atoms on AIP substrate was discussed, which can provide theoretical basis for AIP as the heterogeneous nucleus of Mg₂Si from the energetic theory.

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Experimental procedures and theoretical calculation

Experimental procedures

The Al–20%Mg₂Si alloy used in this study was prepared by casting. Commercial pure Al (99.7%, wt.% in this work), commercial pure crystalline Si (99.9%) and commercial pure Mg (99.8%) were used as raw materials to prepare this experimental alloy in a 25 kW medium frequency induction furnace. The Al–20%Mg₂Si alloy was remelted at 800 °C and held at this temperature for 30 min in a 5 kW electric resistant-heating furnace, and then the melt was poured into a cast iron mold to produce ingots. In order to investigate the influence of phosphorus on Mg₂Si phases, a part of Al–20%Mg₂Si alloy was treated with addition of 3% Al–3%P master alloy at 800 °C and held for 30 min, and then was poured into a cast iron mold to obtain ingots.

All metallographic specimens were cut at the same position of the tabulate samples and then mechanically polished using standard processes. A NaOH water solution (15%) was used as etchant to extract primary Mg₂Si phase from Al–20%Mg₂Si alloy for direct observation of its morphologies. Scanning electron microscope (SEM) (Hitachi Model No. S4800) was carried out to investigate the microstructure characteristics of the specimens.

Computational details

Calculations in this work were performed using the projector augmented wave (PAW) formalism of density functional theory (DFT) [23], as implemented in Vienna ab initio Simulation Package (VASP) [24]. Generalized gradient approximation (GGA) in the form of PW91 was used for the exchange-correlation functional [25]. The tetrahedron method with Blöchl corrections was adopted, and the width of smearing was chosen as 0.1 eV. A plane-wave basis with an energy cutoff of 400 eV was adopted for all the calculations.

AIP and Mg₂Si crystals belong to face-centered cubic structure, and their space groups are F-43m and Fm3m, respectively. According to the lattice disregistry theory [12,26], possible coherent interfaces between AIP and Mg₂Si ((331)_{AIP}/(110)_{Mg₂Si}, (100)_{AIP}/(211)_{Mg₂Si}) can be obtained, and the values of disregistry are 1.10% and 3.87%, respectively. It indicates that AIP can potentially act as heterogeneous nuclei for Mg₂Si phase in these orientation relationships. Therefore, the interface orientation relationships mentioned above were adopted for theoretical study. To ensure the slabs in the interface structures thick enough to show bulk-like characteristics, the convergence tests were conducted on the AIP(3 3 1), AIP(1 0 0), Mg₂Si(1 1 0) and Mg₂Si(2 1 1). It was found that surface energies and interlayer relaxations had good convergence when the slabs thicknesses of AIP(3 3 1), AIP(1 0 0), Mg₂Si(1 1 0) and Mg₂Si(2 1 1) were larger than 11, 5, 5 and 5, respectively. The Brillouin zone was sampled using Monkhorst–Pack scheme [27] with 9 × 9 × 1 k-point grid for the structural relaxation of AIP/Mg₂Si interfaces, and 11 × 11 × 1 for static calculations and electronic structure calculations of all the systems. A vacuum layer (10 Å) was placed on the top of Mg₂Si slabs to separate the free surfaces of Mg₂Si and AIP slabs with an in-plane periodicity to prevent other atomic interaction among the layers.

In order to obtain the stacking sequence of Mg and Si atoms on the AIP surfaces during the formation of the interfaces, adsorption model was adopted. The adsorbed layers were formed by crystallization phase atoms. A 7 × 7 × 1 k-point mesh was used for the calculation of adsorption energy. In the vertical direction, a vacuum layer of about 10 Å in thickness was introduced for all the surfaces.

The geometry optimization was not finished until the Hellmann-Feynman forces less than 0.01 eV/Å for all models.

VESTA was used for structure and electronic visualization and analysis [28].

Results and discussion

Effect of Al–3%P master alloy on the microstructure of Al–20%Mg₂Si alloy

The microstructure of as-cast Al–20%Mg₂Si alloy is presented in Fig. 1. From Fig. 1a, it can be seen that the primary Mg₂Si shows different coarse irregular shapes (two-dimensional observation). The three-dimensional morphologies of the extracted primary Mg₂Si are shown in Fig. 1b–d. These Mg₂Si dendrites exhibit a variety of interesting shapes with inconspicuous crystallographic features of surfaces.

After addition of 3% Al–3%P master alloy in Al–20%Mg₂Si alloy, morphology and size of primary Mg₂Si are obviously changed (Fig. 2a and b). All coarse dendritic Mg₂Si particles disappear and evolve into octahedron (Fig. 2c) and truncated octahedron (Fig. 2d), and their size decreases to ~20 μm. The AIP compound existing in Al–3%P master alloy can act as effective heterogeneous nucleus of Mg₂Si. The rising of nuclei evidently results in an increase in Mg₂Si particles, which leads the growth rate of preferential growth ⟨1 0 0⟩ directions to decelerate [12]. As a result, the enormous dendrite can not be formed along the preferential growth directions, and Mg₂Si grows in the manner of octahedron and truncated octahedron.

Interfaces of AIP/Mg₂Si

In order to confirm the effectiveness of AIP as the heterogeneous nucleus of Mg₂Si, interfacial adhesion work and electronic structures of AIP/Mg₂Si nucleation interfaces were researched by first-principles calculation. According to the terminated types of atoms, AIP(1 0 0) surface can be divided into Al-terminated and P-terminated surfaces. Therefore, three interface models between AIP and Mg₂Si slabs were built according to the results of convergence tests to identify the favorable structure (shown in Fig. 3). All atomic coordinates were allowed for full relaxation. The work of adhesion (W_{ad}) is considered as an important interfacial property to investigate the interface interiors. The value of W_{ad} can evaluate the stability of the interface, and it is defined as the reversible work for separating an interface into two free surfaces, neglecting plastic and diffuse degrees of freedom. The larger the W_{ad} is, the stronger the interface interaction is. The work of adhesion of AIP/Mg₂Si interfaces can be given by [29]:

$$W_{ad} = \left(E_{AIP}^{tot} + E_{Mg_2Si}^{tot} - E_{AIP/Mg_2Si}^{tot} \right) / A \quad (1)$$

where E_{AIP}^{tot} , $E_{Mg_2Si}^{tot}$, and E_{AIP/Mg_2Si}^{tot} are the total energy of the relaxed AIP slabs, Mg₂Si slabs and AIP/Mg₂Si interface system, respectively. A represents the area of interface system.

The values of optimal W_{ad} for different interface geometries are listed in Table 1. From Table 1, it can be obtained that all the values of W_{ad} are positive, indicating that the three AIP/Mg₂Si interfaces all can form steadily. The value of W_{ad} of AIP/Mg₂Si interface exhibits the following sequence: P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface (4.13 J/m²) > Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface (2.73 J/m²) > AIP(3 3 1)/Mg₂Si(1 1 0) (1.03 J/m²). The value of W_{ad} of AIP(1 0 0)/Mg₂Si(2 1 1) is higher than that of AIP(3 3 1)/Mg₂Si(1 1 0), namely, AIP(1 0 0)/Mg₂Si(2 1 1) is more stable than AIP(3 3 1)/Mg₂Si(1 1 0). For the AIP(1 0 0), the adhesion work W_{ad} of P-terminated interface is larger than that of Al-terminated one, suggesting that the binding strength of P-terminated interface is stronger than that of the latter. Meanwhile, the interfacial separation of three interfaces before and after structural relaxation is

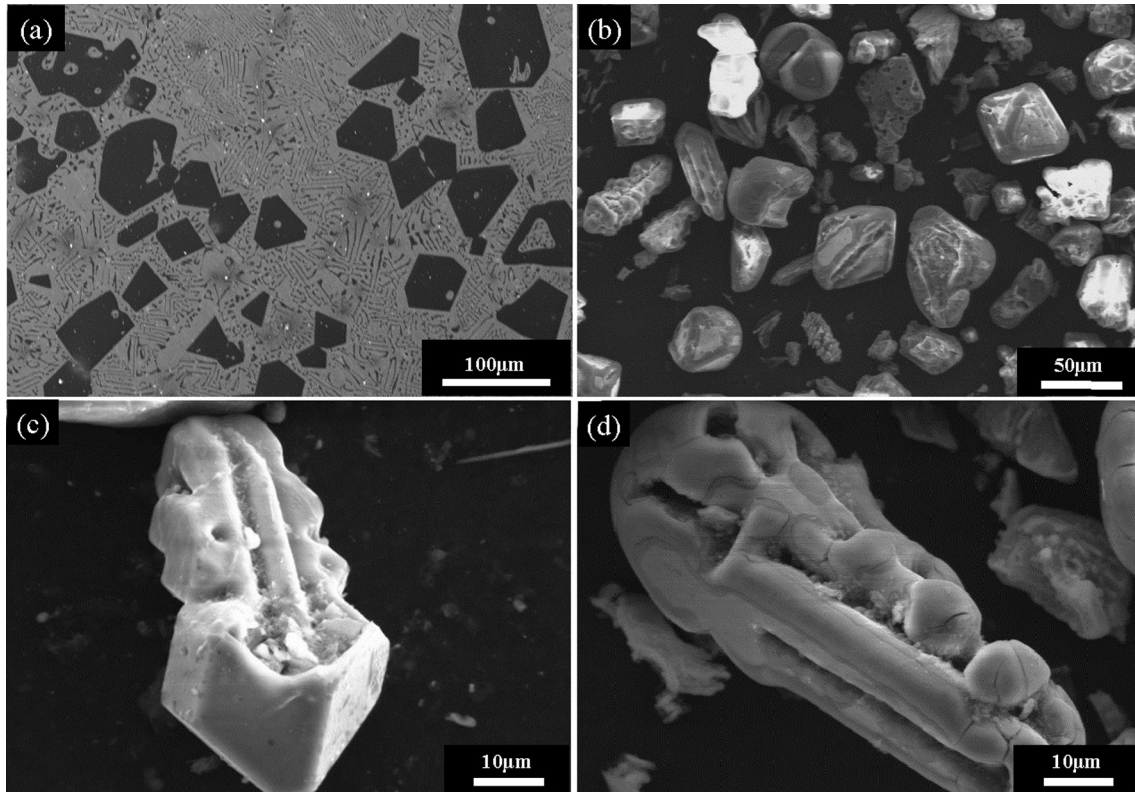


Fig. 1. Microstructures of as-cast Al-20%Mg₂Si alloy: (a) two-dimensional morphologies; (b-d) three-dimensional morphologies.

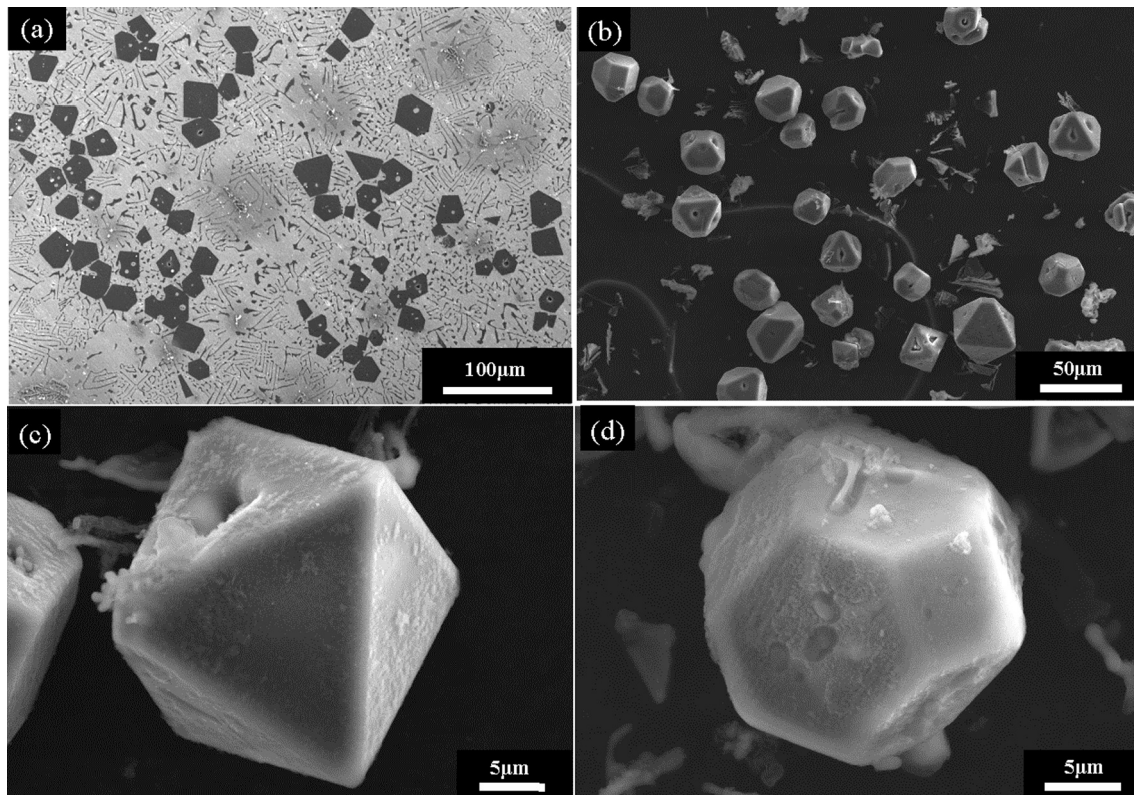


Fig. 2. Microstructures of Al-20%Mg₂Si alloy with addition of 3%Al-3%P master alloy: (a) two-dimensional morphologies; (b-d) three-dimensional morphologies.

also listed in Table 1. The d_0 and d_1 are the interfacial distances before and after the relaxation, respectively. It can be seen that the interfacial distances of three interfaces before relaxation are

equivalent (2.50 Å). After structural relaxation, the interfacial distances of the three interfaces all decrease. In addition, the interfacial distance of interface (c) is the smallest (0.78 Å) among the

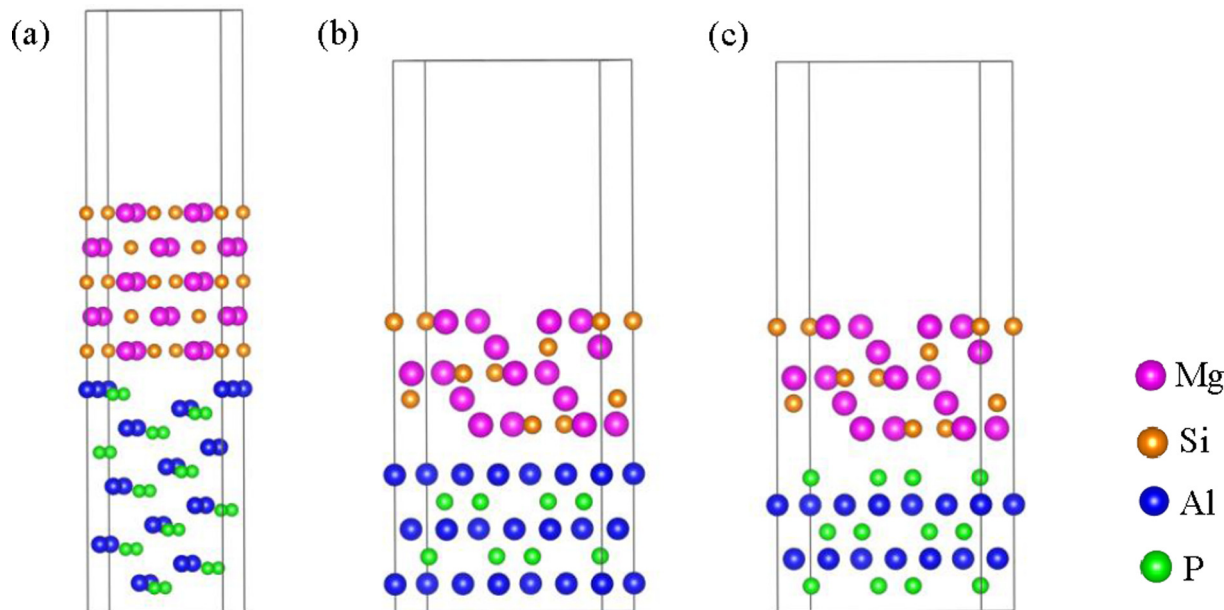


Fig. 3. Three models of AIP/Mg₂Si interfaces: (a) AIP(3 3 1)/Mg₂Si(1 1 0); (b) Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1); (c) P-terminated AIP(1 0 0)/Mg₂Si(2 1 1).

Table 1
The work of adhesion (W_{ad}) and interfacial distance before (d_0) and after (d_1) relaxation for different interfaces.

Interface	d_0 (Å)	d_1 (Å)	W_{ad} (J/m ²)
AIP(3 3 1)/Mg ₂ Si(1 1 0)	2.50	1.71	1.03
Al-terminated AIP(1 0 0)/Mg ₂ Si(2 1 1)	2.50	1.10	2.73
P-terminated AIP(1 0 0)/Mg ₂ Si(2 1 1)	2.50	0.78	4.13

three kinds of interfaces, indicating that P-terminated AIP(1 0 0) surface is more reactive and ready to form bonds. The reason may be that Mg and Si atoms in Mg₂Si tend to have strong interaction with P atoms in AIP(1 0 0) slabs, and the orientation relationships lead to a large W_{ad} . Thus, the P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface is considered to be the most favorable structure in the three interface models in the view of work of adhesion.

In order to further ascertain the interfacial binding, the electronic structures of the three AIP/Mg₂Si interfaces were also explored, which can be discussed by charge density difference and partial density of states (PDOS). The charge density difference can be calculated by the following formula:

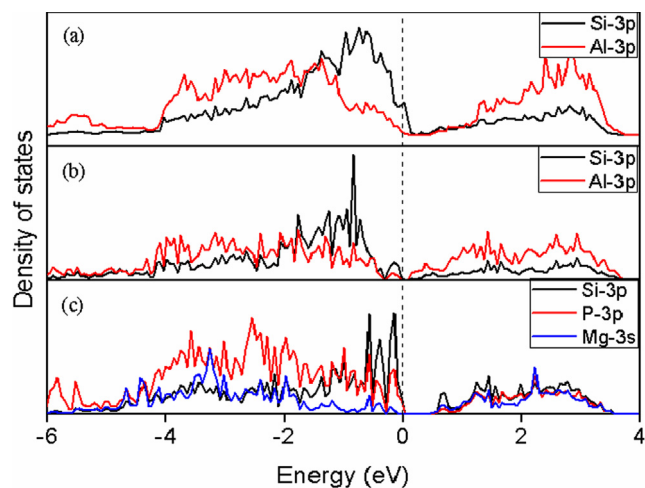


Fig. 5. The partial density of states (PDOS) of the atoms (marked by arrows in Fig. 4) at the interface: (a) AIP(3 3 1)/Mg₂Si(1 1 0); (b) Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1); (c) P-terminated AIP(1 0 0)/Mg₂Si(2 1 1). The PDOS of Al 3p and Mg 3s are enhanced by 3 times to show clearly. Dotted line represents Fermi energy level.

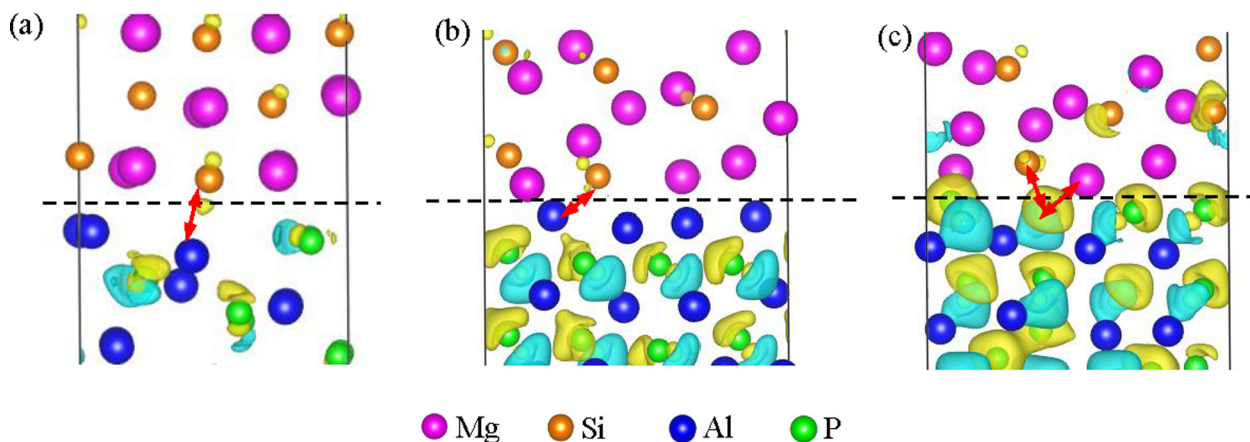


Fig. 4. Charge density difference map of AIP/Mg₂Si interfaces: (a) AIP(3 3 1)/Mg₂Si(1 1 0); (b) Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1); (c) P-terminated AIP(1 0 0)/Mg₂Si(2 1 1). The isosurface value is 0.05 e/Å³. Yellow and blue represent the enrichment and loss of electrons, respectively. Dotted line indicates the interface position. (For interpretation of the references to colour in this figure legend, the reader is referred to the web version of this article.)

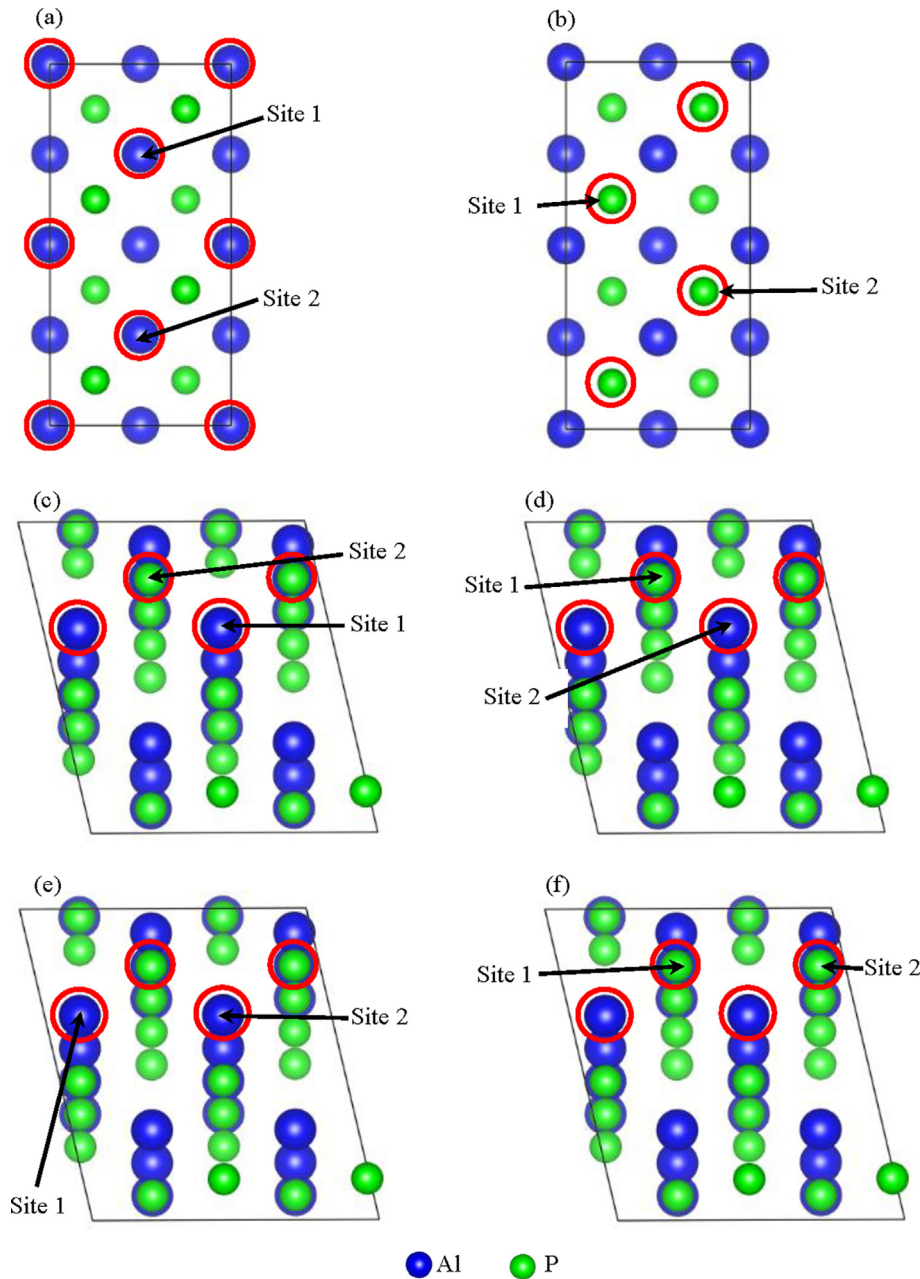


Fig. 6. Top view of adsorption sites: (a) Al-terminated AIP(1 0 0); (b) P-terminated AIP(1 0 0); (c–f) AIP(3 3 1). Mg, Si atoms are on top-site of Al or P, and site 1 stands for Mg atom, site 2 stands for Si atom. Atoms in red circles are at the first atomic layer. (For interpretation of the references to colour in this figure legend, the reader is referred to the web version of this article.)

Table 2
Data of adsorption energy (E_{ads}) of different adsorption models.

Surface	Adsorption site	E_{ads} (eV)
AIP(1 0 0)	(a) Al-terminated: Mg, Si on top of Al	5.20
	(b) P-terminated: Mg, Si on top of P	6.98
AIP(3 3 1)	(c) Mg on top of Al, Si on top of P	4.60
	(d) Mg on top of P, Si on top of Al	4.67
	(e) Mg, Si on top of Al	5.14
	(f) Mg, Si on top of P	3.78

$$\Delta\rho = \rho_{\text{total}} - \rho_{\text{AIP}} - \rho_{\text{Mg}_2\text{Si}} \quad (2)$$

where ρ_{total} is the total charge density of AIP/Mg₂Si interface, ρ_{AIP} and $\rho_{\text{Mg}_2\text{Si}}$ represent the charge density of isolated AIP slabs and Mg₂Si slabs, respectively.

After relaxation, the charge density difference of AIP/Mg₂Si interfaces is shown in Fig. 4. It can be seen that chemical bonds are formed between interfacial atoms of Mg₂Si and AIP sides, while the strength of bonding is different. For AIP(3 3 1)/Mg₂Si(1 1 0), a small charge accumulation region exists between interfacial Si atoms of Mg₂Si side and Al atoms of AIP side (Fig. 4a), indicating that only a relatively weak chemical bond is formed at the interface. Also for Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface, there is the similar situation (Fig. 4b). In Fig. 4c, the bonding strength of P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface is obviously stronger than that of the other two. Moreover, chemical bonds with considerable strength are formed among the interfacial Mg, Si atoms of Mg₂Si side and P atoms of AIP side.

The partial density of states (PDOS) was adopted in this work to give further insight into the details of the interaction between the AIP slabs and Mg₂Si slabs. Fig. 5 shows PDOS of the atoms (marked

by arrows in Fig. 4) at the interface. Peaks of Si-3p and Al-3p orbitals (Fig. 5a and b) are superposed near the Fermi energy, illustrating that Si-Al covalent bonds are formed in the two interfaces. The PDOS analysis of P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface is shown in Fig. 5c. It can be seen that the covalent bonds with great strength exist in interfacial atoms due to the electron orbital hybridization in valence band between the 3p states of Si and P, as well as 3s states of Mg atom and P-3p states. This is in good agreement with the charge density difference analysis.

Stacking sequence of Mg, Si atoms on AIP

Based on the results calculated above, adsorption model was put forward to simulate the stacking sequence of Mg, Si atoms on AIP interfaces. In this particular study, Mg and Si atoms on the AIP substrate were regarded as an adsorbed layer. For simplicity, only one Mg atom and one Si atom were used for all the models in this part, and Mg and Si atoms were on top-site of Al or P atoms (shown in Fig. 6). The adsorption energy of Mg, Si atoms is defined as follows:

$$E_{\text{ads}} = E_{\text{AIP}} + E_{\text{atoms}} - E_{\text{AIP/atoms}} \quad (3)$$

where E_{AIP} and $E_{\text{AIP/atoms}}$ represent the energy of clean AIP slabs and the slabs with adsorbed Mg and Si atoms, respectively. E_{atoms} is the energy of Mg and Si atoms. It can be inferred that the adsorption model is stable when E_{ads} is positive. And the more positive value of E_{ads} indicates the stronger interaction between the Mg, Si atoms and AIP substrate surface.

The calculated results of adsorption energy for the six adsorption models (shown in Fig. 6) are given in Table 2. The E_{ads} of Mg, Si atoms and AIP surfaces are all positive, and it is inferred that the adsorption between Mg, Si atoms and AIP is thermodynamically favorable. Furthermore, Mg and Si atoms tend to be adsorbed on the surface firstly where the E_{ads} is larger. From Table 2, it can be observed that, for AIP(1 0 0) surface, Mg and Si atoms prefer to be adsorbed on P-terminated AIP(1 0 0) firstly. However, for AIP(3 3 1), Mg and Si atoms would like to be adsorbed on top-site of Al atoms preferentially. On the initial stage, Mg and Si atoms in Al-Mg₂Si melt surround AIP particles randomly. Because of the interaction between Mg, Si atoms and AIP(1 0 0) or (3 3 1), Mg and Si atoms tend to be adsorbed on the AIP as an adsorbed layer. In the layer, Mg and Si atoms can be arranged. As temperature decreases, the adsorbed layer transforms into Mg₂Si crystal driven by undercooling and AIP/Mg₂Si interfaces are formed in term of adsorption model [30,31]. AIP particles can act as high efficiency nucleating agent for primary Mg₂Si. As a result, primary Mg₂Si particles change from coarse dendrite to fine octahedron/truncated octahedron by increase of the Mg₂Si crystal nuclei.

Conclusion

In this paper, experimental observation and theoretical calculation were carried out to reveal the heterogeneous nucleation potential of AIP for primary Mg₂Si in Al-Mg₂Si alloys. The interfacial atomic structure, work of adhesion (W_{ad}), electronic structure of AIP(1 0 0)/Mg₂Si(2 1 1) and AIP(3 3 1)/Mg₂Si(1 1 0) interfaces were investigated using first-principles calculations. The main conclusions are summarized as follows:

- (1) For AIP(1 0 0)/Mg₂Si(2 1 1) and AIP(3 3 1)/Mg₂Si(1 1 0) interfaces, the W_{ad} exhibits the following sequence: P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface (4.13 J/m²) > Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface (2.73 J/m²) > AIP(3 3 1)/Mg₂Si(1 1 0) interface (1.03 J/m²).
- (2) For P-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interface, the chemical bonds are formed between the interfacial Mg, Si atoms of Mg₂Si side and P atom of AIP side. For AIP(3 3 1)/Mg₂Si(1 1 0) and Al-terminated AIP(1 0 0)/Mg₂Si(2 1 1) interfaces, there is a only relatively weak chemical bond between interfacial Si atom of Mg₂Si side and Al atom of AIP side.
- (3) The morphologies of primary Mg₂Si particles change from coarse dendrite to fine octahedron/truncated octahedron (~20 μm), due to the existence of AIP as the effective heterogeneous nucleus of Mg₂Si.

Acknowledgments

This work was supported by a grant from National Natural Science Foundation of China (No. 51404169 and No. 51774212), National Science Fund for Distinguished Young Scholars of China (No. 51325401) and Natural Science Foundation of Tianjin (No. 15JQJNC03200). The calculation work was carried out at National Supercomputer Center in Tianjin, and the calculations were performed on TianHe-1 (A). The authors are grateful to Associate Professor Enzuo Liu at Tianjin university for his calculation discussion.

Appendix A. Supplementary data

Supplementary data associated with this article can be found, in the online version, at <https://doi.org/10.1016/j.rinp.2017.11.025>.

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